

OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Applicant Information**

Applicant Authority type:: Inventor
 Primary Citizenship Country:: Japan
 Status:: Full Capacity
 Given Name:: Tsuyoshi
 Family Name:: NISHIZAWA
 City of Residence:: Nishishirakawa-gun
 Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Application Type:: National Phase
 Subject Matter:: Utility
 CD-ROM or CD-R:: None
 Title:: METHOD FOR PRODUCING SILICON
 EPITAXIAL WAFER AND SILICON
 EPITAXIAL WAFER
 Attorney Docket Number:: 126273
 Suggested Drawing Figure:: 1
 Total Drawing Sheets:: 12
 Small Entity:: No

Representative Information

Attorneys associated with Customer No. 25944.

| Domestic Priority Information | | | |
|-------------------------------|-------------------|----------------------|----------------------|
| Application:: | Continuity Type:: | Parent Application:: | Parent Filing Date:: |
| | | | |
| This Application is a | National Stage of | PCT/JP2004/008725 | 06/21/04 |
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|---|----------------------|-------------------------------------|--------------------|
| Foreign Priority Information | | | |
| Country:: | Application Number:: | Filing Date:: | Priority Claimed:: |
| | | | |
| Japan | 2003-182615 | 06/26/03 | Yes |
| | | | |
| Assignee Information | | | |
| Assignee Name:: | | Shin-Etsu Handotai Co., Ltd. | |
| Street of mailing address:: | | 4-2, Marunouchi 1-chome, Chiyoda-ku | |
| City of mailing address:: | | Tokyo | |
| Country of mailing address:: | | Japan | |
| Postal or Zip Code of mailing address:: | | 100-0005 | |